



MEMC 99-0900/2632
PATENT

#6

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Art Unit 1765

Application of Robert H. Fuerhoff et al.

Serial No. 09/502,340

Filed February 10, 2000

Confirmation No. 5009

For METHOD AND APPARATUS FOR CONTROLLING DIAMETER OF A SILICON
CRYSTAL IN A LOCKED SEED LIFT GROWTH PROCESS

Examiner M. Anderson

May 15, 2001

LETTER TO THE OFFICIAL DRAFTSMAN

TO THE COMMISSIONER OF PATENTS AND TRADEMARKS
SIR:

In compliance with the notice in Form PTO 948 in the above-entitled application,
applicant files herewith ten sheets of formal drawings to replace the drawings now on
file.

Respectfully submitted,

Robert M. Bain, Reg. No. 36,736
SENNIGER, POWERS, LEAVITT & ROEDEL
One Metropolitan Square, 16th Floor
St. Louis, Missouri 63102
(314) 231-5400

Express Mail Label No. EL 739386125 US

RECEIVED
MAY 21 2001
TC 1700 MAIL ROOM